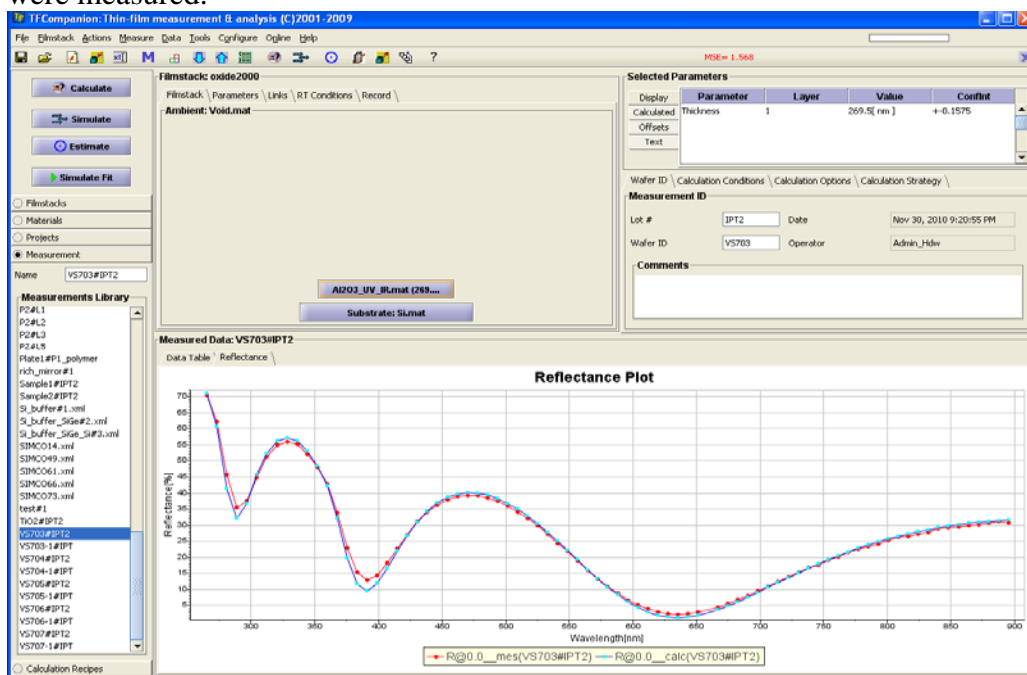




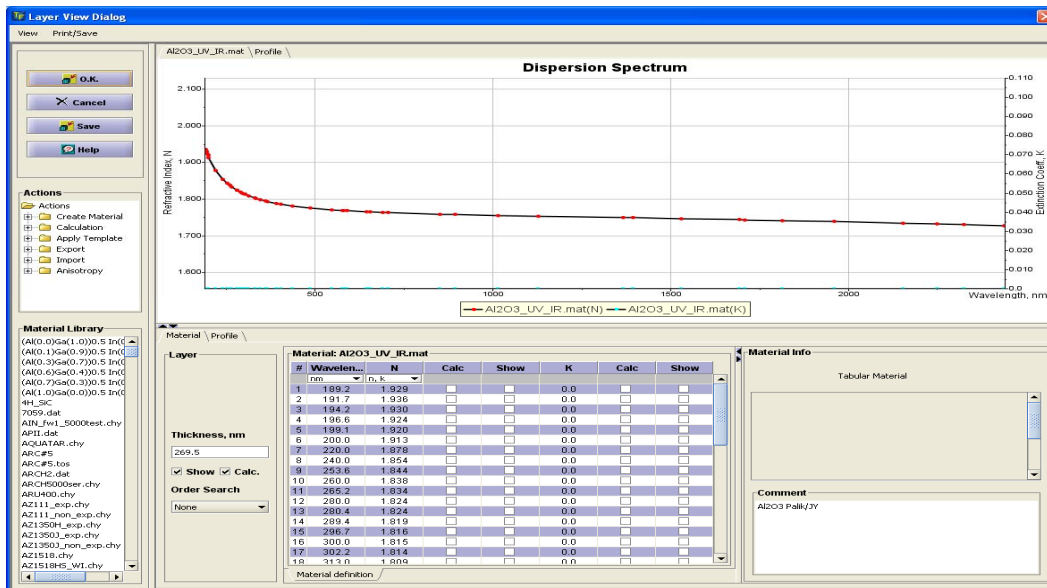
*Thin Film Measurement solution  
Software, sensors, custom development  
and integration*

## **Heterostructure samples measurement**

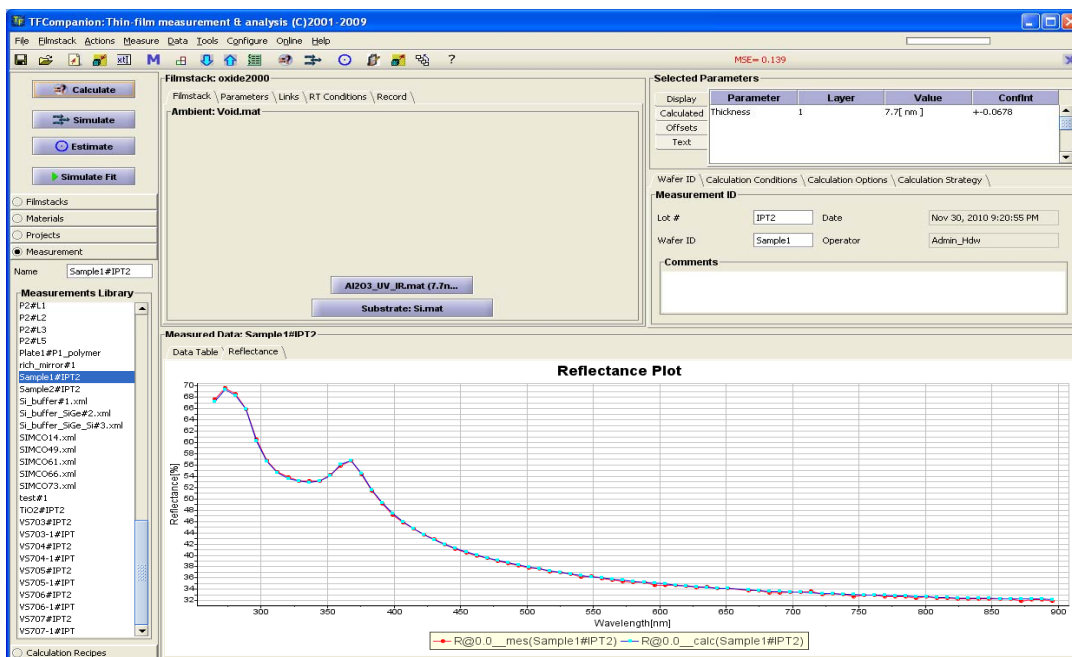
ZnO based heterostructures are used for LED applications. Multiple pairs of identical layers are used in heterostructure to amplify the light emission. MProbe UVVisSr system (200nm -1000nm) was used to measure the thickness of the layers and verify their optical dispersion. Heterostructure had ZnO and Al<sub>2</sub>O<sub>3</sub> layer pairs repeated 60 times (ZnO/Al<sub>2</sub>O<sub>3</sub>) x 60. To determine optical constants of ZnO and Al<sub>2</sub>O<sub>3</sub> two thick sample of these materials were measured.



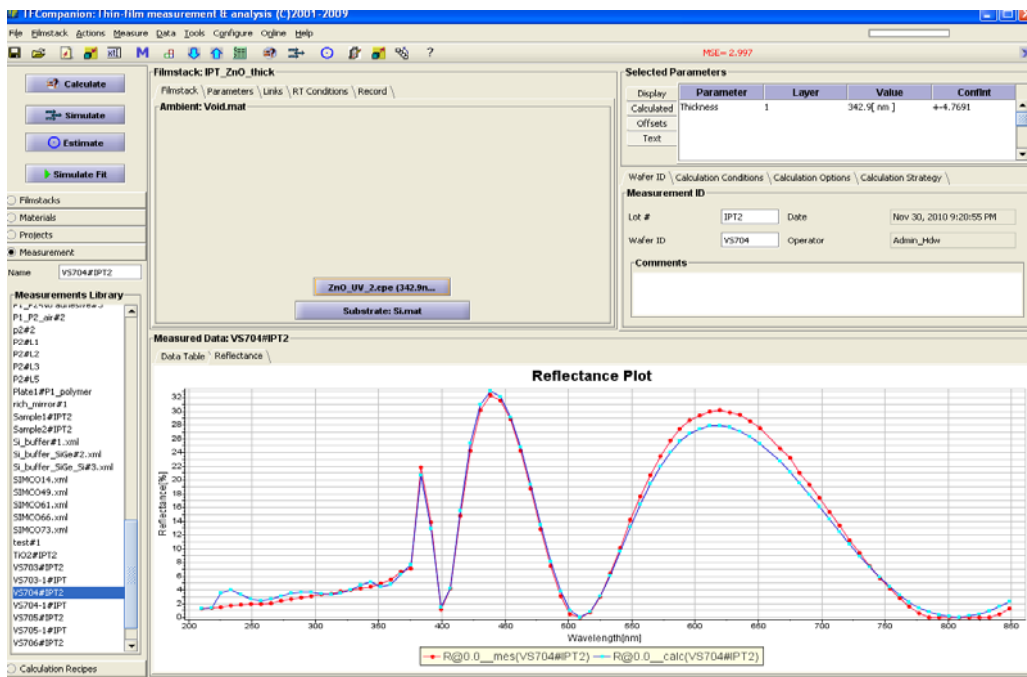
**Fig. 1** Measurement of the thick Alumina sample: model to measurement fit. Thickness and optical constants of the Al<sub>2</sub>O<sub>3</sub> were determined. Measured thickness: 269 nm (optical dispersion see Fig. 2)



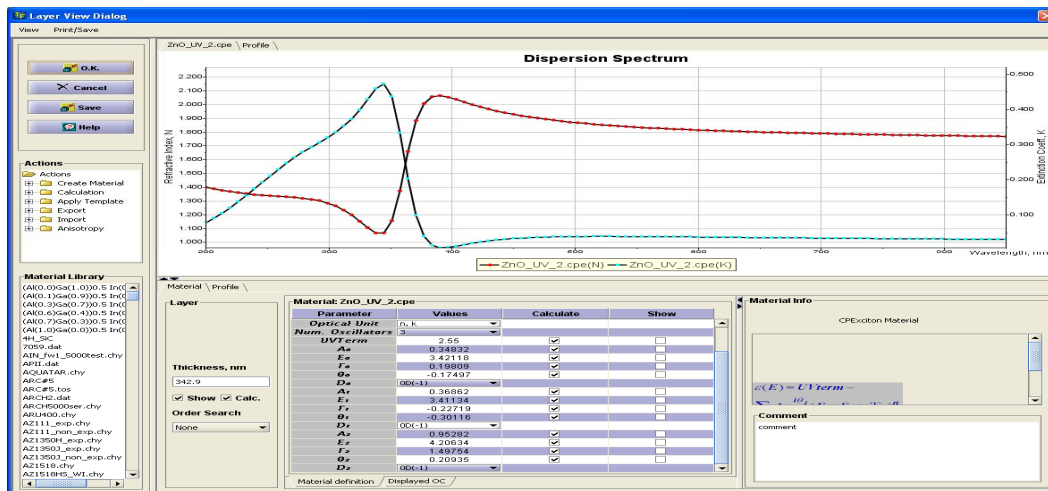
**Fig. 2** Optical dispersion of the Al<sub>2</sub>O<sub>3</sub> determined from the measurement. Dispersion is represented using Cauchy approximation.



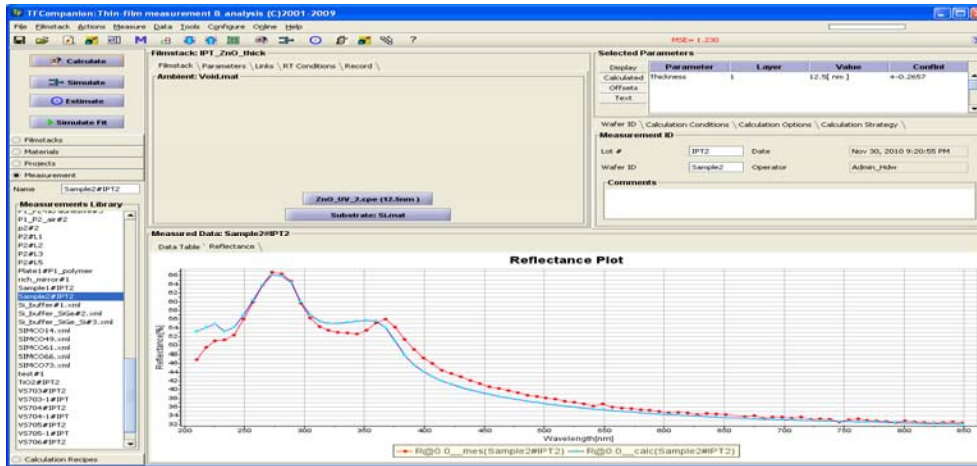
**Fig. 3** Thin Al<sub>2</sub>O<sub>3</sub> sample. Optical dispersion determined from the thick Al<sub>2</sub>O<sub>3</sub> sample was used here to verify the sample properties are valid for a thin film. Thickness was determined 7.7nm. The chart shows fit of the model to measured data



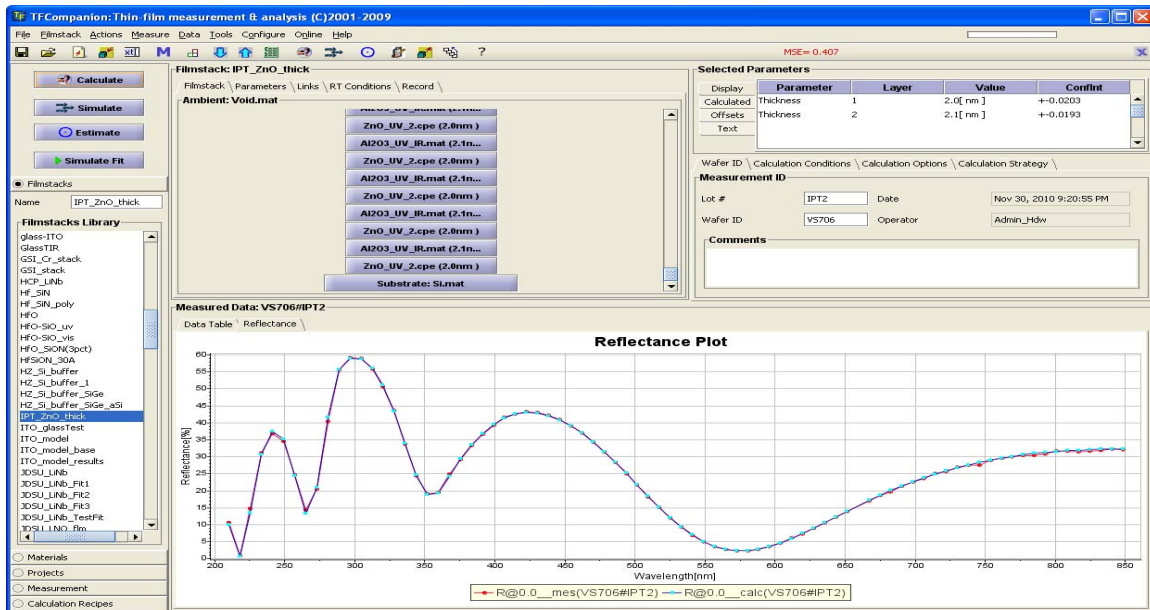
**Fig. 4** Thick ZnO film: fit of the model to measured data. Thickness and optical dispersion are determined from the fit. Thickness: 342 nm



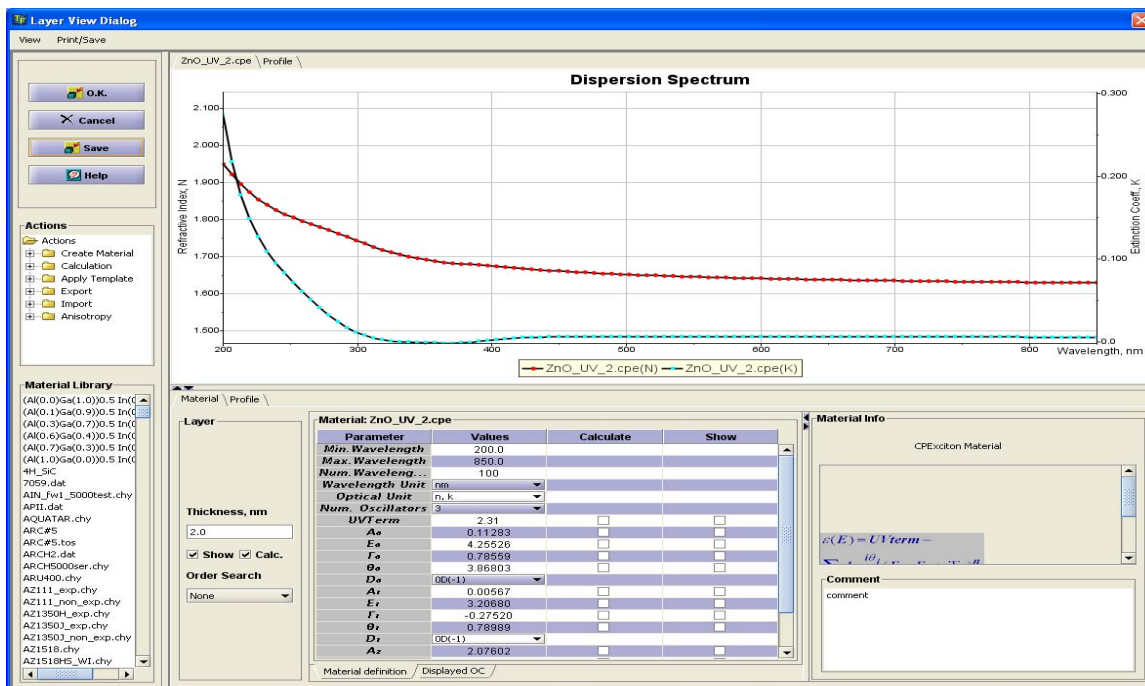
**Fig. 5** Optical dispersion of the ZnO determined from the measurement of the thick ZnO sample. Dispersion is represented using CP Exciton model



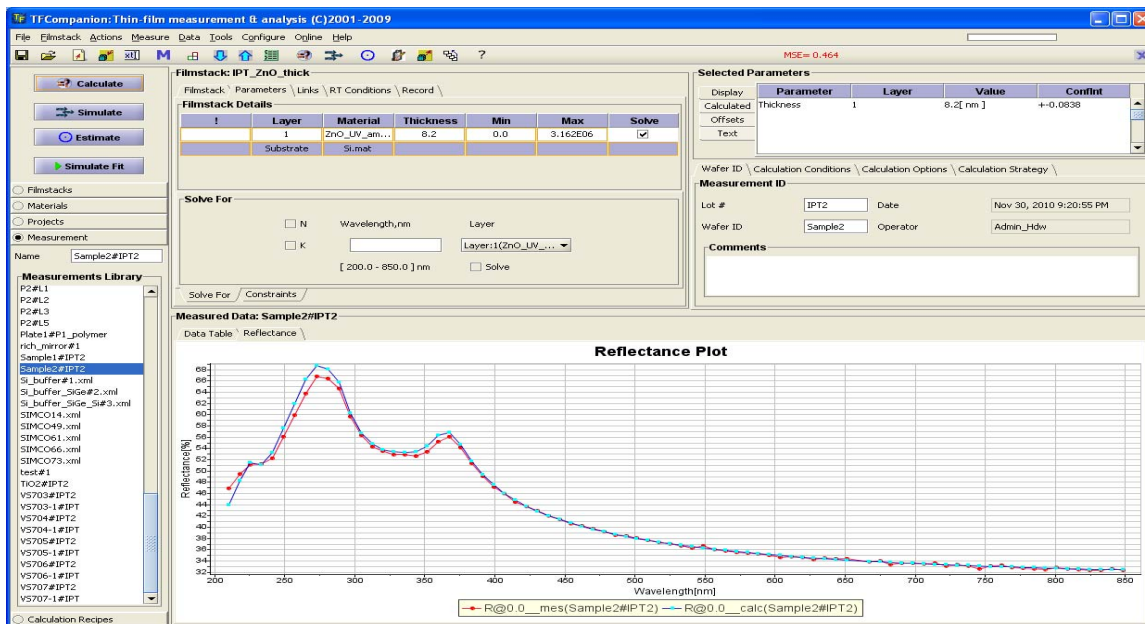
**Fig. 6.** Thin ZnO sample. Model to measurement fit using optical dispersion determined from the thick ZnO sample. Thickness: 12nm. Discrepancies in the fit indicate that optical properties of the thin ZnO sample are different from the thick one – it appears more amorphous.



**Fig. 7** Model fit to the measured data for (2.0 nm ZnO/2.1nm Alumina) $\times$ 60 /Si heterostructure sample. Thicknesses of Alumina and ZnO layers were determined - all repeated layer were assumed the same (same thickness and dispersion). ZnO dispersion was determined from the measurement.



**Fig. 8.** ZnO dispersion determined from heterostructure measurement. Dispersion is smooth without critical point – indicating almost completely amorphous material.



**Fig. 9** ZnO dispersion determined from heterostructure measurement was used to analyze thin ZnO sample - to verify that it is indeed correct. The good fit shows that ZnO dispersion is the same in a single ZnO layer and ZnO layers in heterostructure.